

<b>Notice of References Cited</b>	Application/Control No. 10/596,416	Applicant(s)/Patent Under Reexamination TSUDA, AKIMITSU	
	Examiner LUCY P. CHIEN	Art Unit 2871	Page 1 of 1

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*	A	US-2004/0100423	05-2004	Nagakubo et al.	345/040
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	L	US-			
	M	US-			

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**NON-PATENT DOCUMENTS**

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	Machine translation of JP 2001-067049
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